

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ryoichi Mukai

Serial No.: 10458,662

Conf. No.: 3822

Filed: January 28, 2002

For: POLYCRYSTALLINE STRUCTURE FILM  
AND METHOD OF MAKING SAME

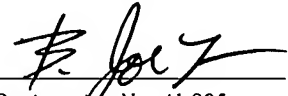
Art Unit: 1771

Examiner: Piziali, Andrew T.

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

August 16, 2007

Date

  
Registration No. 41,895  
Attorney for Applicant(s)**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit a Corrected Form PTO-1449 to replace the Form PTO-1449 filed on August 6, 2007. Applicants inadvertently listed the publication date of KR 1985-0005006 as July 26, 1989. The correct date should be --August 19, 1985--.

It is respectfully requested that the above-listed document be made of record in the present application.

Respectfully submitted,

GREER, BURNS &amp; CRAIN, LTD.

By

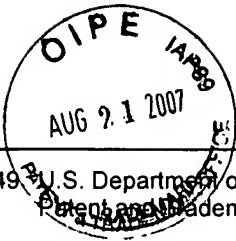


B. Joe Kim

Registration No. 41,895

August 16, 2007

300 South Wacker Drive  
Suite 2500  
Chicago, Illinois 60606-6501  
Telephone: (312) 360-0080  
Facsimile: (312) 360-9315



## CORRECTED FORM PTO-1449

Sheet 1 of 1

Form PTO-1449, U.S. Department of Commerce  
(Rev. 8-88) Patent and Trademark Office

Attorney Docket No.: 2500.66134

Serial No.: 10/058,662

Applicant: Ryoichi Mukai

INFORMATION DISCLOSURE CITATION  
(Use several sheets if necessary)

Filing Date: January 28, 2002

Group: 1771

## U.S. PATENT DOCUMENTS

| Examiner Initial* | Document Number | Date          | Name             | Class | Subclass | Filing Date If Appropriate |
|-------------------|-----------------|---------------|------------------|-------|----------|----------------------------|
|                   | RE37,748        | Jun. 18, 2002 | Chen et al       |       |          |                            |
|                   | 5,658,659       | Aug. 19, 1997 | Chen et al.      |       |          |                            |
|                   | 5,736,013       | Apr. 7, 1998  | Ranjan et al.    |       |          |                            |
|                   | 5,851,688       | Dec. 22, 1998 | Chen et al.      |       |          |                            |
|                   | 5,976,326       | Nov. 2, 1999  | Ranjan et al.    |       |          |                            |
|                   | 6,013,161       | Jan. 11, 2000 | Chen et al.      |       |          |                            |
|                   | 4,606,802       | Aug. 19, 1986 | Kobayashi et al. |       |          |                            |
|                   |                 |               |                  |       |          |                            |

## FOREIGN PATENT DOCUMENTS

|  | Document Number | Date          | Country | Class | Subclass | Translation |    |
|--|-----------------|---------------|---------|-------|----------|-------------|----|
|  |                 |               |         |       |          | Yes         | No |
|  | 8-50715         | Feb. 20, 1996 | Japan   |       |          | X*          |    |
|  | 1985-0005006    | Jul. 26, 1989 | Korea   |       |          | X**         |    |
|  | 1985-0005006    | Aug. 19, 1985 | Korea   |       |          | X**         |    |
|  |                 |               |         |       |          |             |    |
|  |                 |               |         |       |          |             |    |
|  |                 |               |         |       |          |             |    |
|  |                 |               |         |       |          |             |    |
|  |                 |               |         |       |          |             |    |

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

|  |  |
|--|--|
|  |  |
|  |  |
|  |  |
|  |  |
|  |  |
|  |  |
|  |  |
|  |  |
|  |  |
|  |  |

Examiner

Date Considered

\*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

\* Corresponds to U.S. Patent Nos. RE37,748; 5,658,659; 5,736,013; 5,851,688; 5,976,326; 6,013,161.

\*\* Corresponds to U.S. Patent No. 4,606,802.